Application No. 10/643,751
Paper Dated November 19, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.

10/643,751

Applicant

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Attorney Docket No. 116-031357

KENTARO YAMAGUCHI ET AL.

Filed

:

August 19, 2003

Title

ELECTROSPRAY MASS SPECTROMETER AND ION SOURCE

Group Art Unit

Not Yet Assigned

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CLAIM FOR PRIORITY UNDER 35 U.S.C. § 119

Sir:

Applicants claim priority to Japanese Patent Application Nos. 2002-237793 and 2003-190067 which correspond to the above-identified United States patent application and which were filed in the Japanese Patent Office on August 19, 2002 and July 2, 2003, respectively. Certified copies of the priority documents will follow. The priority benefits provided by Section 119 of the Patent Act of 1952 are claimed for the above application.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 19, 2003.

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(Name of Person Mailing Paper)

Signature

11/19/03

Date